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UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant.

Charles M. McKenna et al.

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ION IMPLANTER HAVING TWO-STAGE DECELERATION

BEAMLINE

Examiner:

Mary A. El-Shammaa

Art Unit:

2881

CERTIFICATE OF MAILING UNDER 37 C.F.R. §1.8(a)

The undersigned hereby certifies that this document is being placed in the United States mail with first-class postage attached, addressed to Mail Stop RCE, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the 2 day of August, 2004.

Cheryl Purcell

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Sir:

Transmitted herewith are the following documents:

- [X] Final Amendment
- [X] Four-month Petition for Extension of Time
- [X] Request for Continued Examination
- [X] Return Receipt Postcard

If any fees are determined to be required or if there are any overpayments, Deposit Account 50-0896 may be charged or credited.

Respectfully submitted,

Charles M. McKenna et al., Applicants

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